

<b>Notice of References Cited</b>	Application/Control No. 10/561,164		Applicant(s)/Patent Under Reexamination TIAN ET AL.	
	Examiner Sean Basquill		Art Unit 1612	Page 1 of 1

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*	B	US-6,579,862	06-2003	Pratap et al.	514/169
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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